



1449-A and B (Modified)		APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>		FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
		APPLICANT: Fufang Zha et al.	
		GROUP ART UNIT: 1797	EXAMINER: Menon, Krishnan S.
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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>			FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
			APPLICANT: Fufang Zha et al.	
			GROUP ART UNIT: 1797	EXAMINER: Menon, Krishnan S.
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#EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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